

DOCKET NO: 296428US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TSUYOSHI TAKAHASHI, ET AL. : EXAMINER: MILLER, JR, J.A.
SERIAL NO: 10/593,254 :
FILED: SEPTEMBER 18, 2006 : GROUP ART UNIT: 1792
FOR: METHOD AND APPARATUS FOR :
FORMING METAL SILICATE FILM, AND
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated December 2, 2008, please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.